Docket No.: 1794-0141P (PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Yoshinobu AOYAGI et al.

Application No.: 09/941.612 Confirmation No.: 6758

Filed: August 30, 2001

Art Unit: 1792

For: IMPURITY DOPING METHOD FOR

SEMICONDUCTOR AS WELL AS SYSTEM THEREFOR AND SEMICONDUCTOR MATERIALS PREPARED THEREBY

Examiner: M. J. Song

## AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## INTRODUCTORY COMMENTS

In response to the Examiner's Office Action dated October 29, 2009, the period for response having been extended two (2) months to March 29, 2010, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application.

## This reply includes

Amendments to the Claims;

Remarks: and

Declaration under 37 C.F.R. §1.132.